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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Robert J. Small and Zhefei J. Chen
Title: Compositions for Chemical-Mechanical Planarization of Noble-Metal-Featured Substrates, Associated Methods, and Substrates Produced By Such Methods
Application No.: 10/057,206 Filing Date: January 25, 2002
Examiner: Michael Marcheschi Group Art Unit: 1755
Docket No.: CHEM.003US0 Conf. No.: 1702

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Signature Carleen Bower

COMMISSIONER FOR PATENTS
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AMENDMENT

Sir:

This is in response to a first office action that was mailed on April 29, 2003, setting a shortened statutory period for response that expired on July 29, 2003. A three-month extension of time is hereby requested. In view of the following amendment and remarks, reconsideration is respectfully requested.

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